## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Scott Mordin Hoyte, et al.

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For: MI

METHODS AND SYSTEMS

FOR MONITORING

MACHINERY

## AMENDMENT AFTER FINAL

Mail Stop: AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

In response to the Office Action dated July 11, 2008, Applicants respectfully request consideration and entry of the following amendment.

DO NOT ENTER: /RJ/

09/15/2008